

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Eva Tois et al.
App. No	:	10/678,766
Filed	:	October 2, 2003
For	:	METHOD OF GROWING OXIDE THIN FILMS
Examiner	:	Matthew Song
Art Unit	:	1714
Conf No.	:	1629

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants respectfully disagree with the Examiner's statement of reasons for allowance to the extent it implies that the Examiner made a prima facie case of obviousness. Applicants disagree that a prima facie case of obviousness was made by the Examiner with the cited references.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: September 28, 2010

By: David K. Buckingham

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